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(54) **SEMICONDUCTOR APPARATUS AND AN IMPROVED STRUCTURE FOR POWER LINES**

(71) Applicant: **SK hynix Inc.**, Icheon-si, Gyeonggi-do (KR)

(72) Inventor: **Su Hyun Kim**, Icheon-si (KR)

(73) Assignee: **SK Hynix Inc.**, Gyeonggi-do (KR)

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**G11C 5/06** (2006.01)

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(58) **Field of Classification Search**

CPC ..... H01L 23/50; H01L 23/5286  
See application file for complete search history.

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*Primary Examiner* — Selim Ahmed

*Assistant Examiner* — Wasiul Haider

(74) *Attorney, Agent, or Firm* — William Park & Associates Ltd.

(57) **ABSTRACT**

A semiconductor apparatus includes a first power supply pad configured to supply a first power; a second power supply pad configured to supply a second power; a first power line configured to be directly electrically coupled to the first power supply pad; and a second power line configured to be directly electrically coupled to the second power supply pad.

**19 Claims, 5 Drawing Sheets**

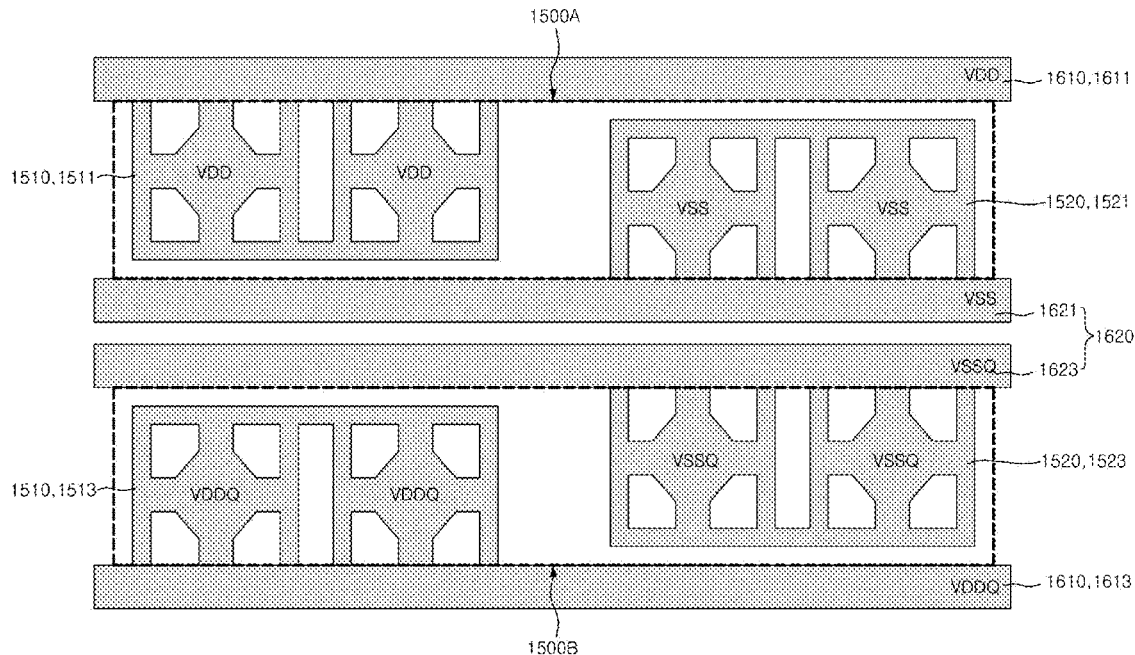


FIG.1

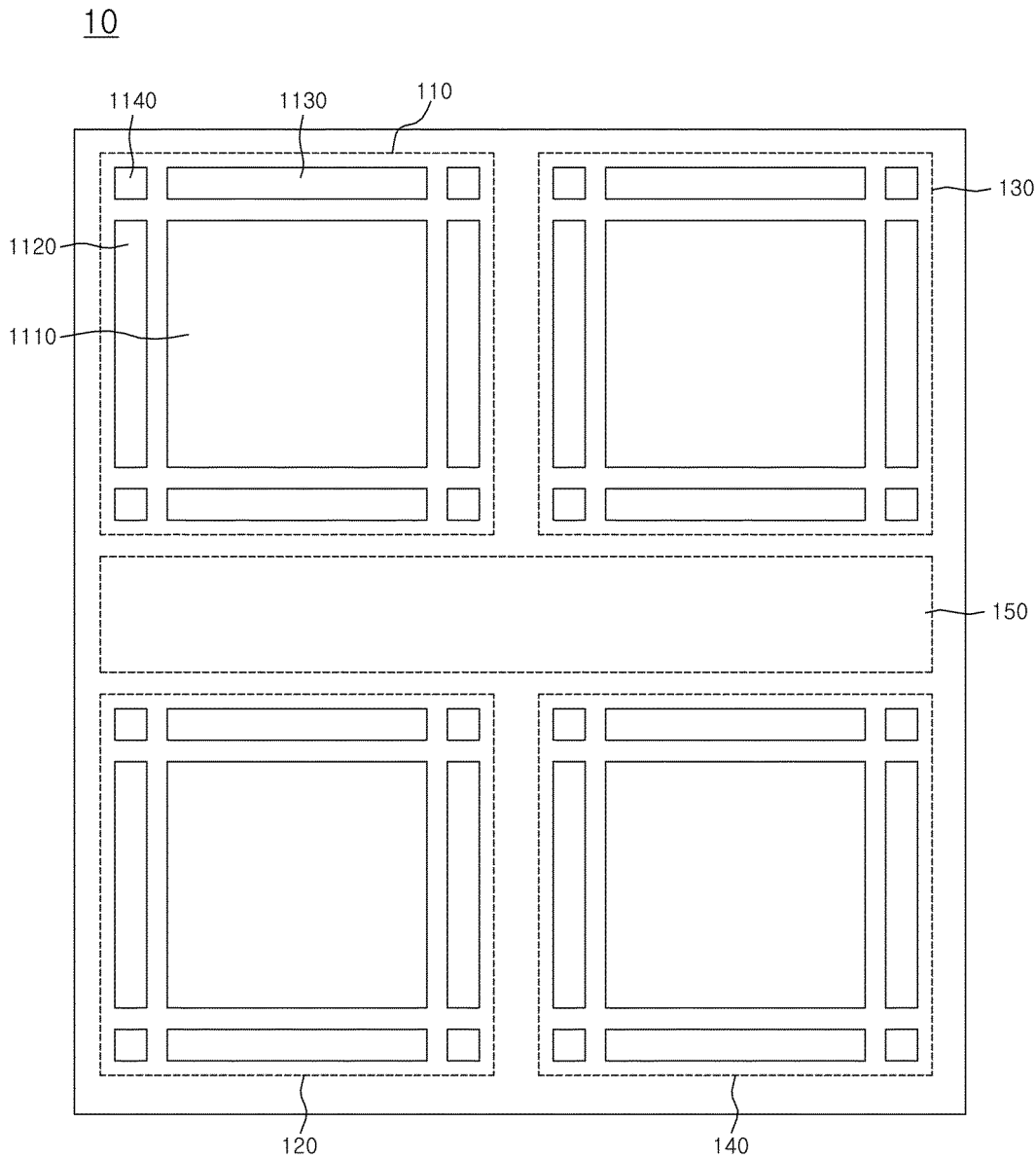


FIG.2

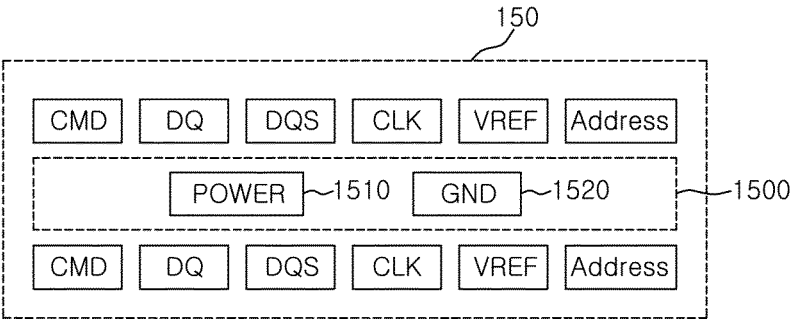


FIG. 3

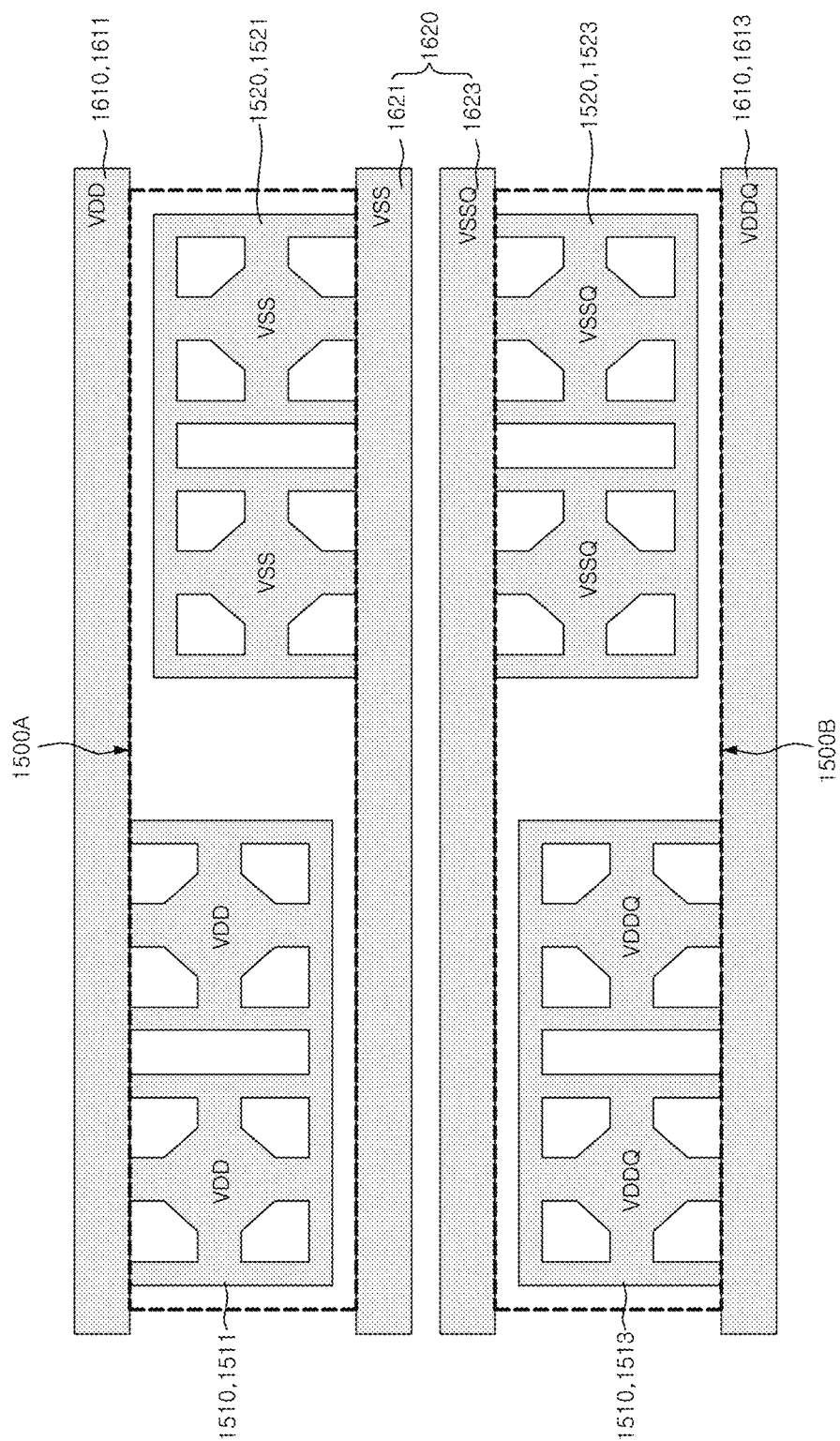


FIG. 4

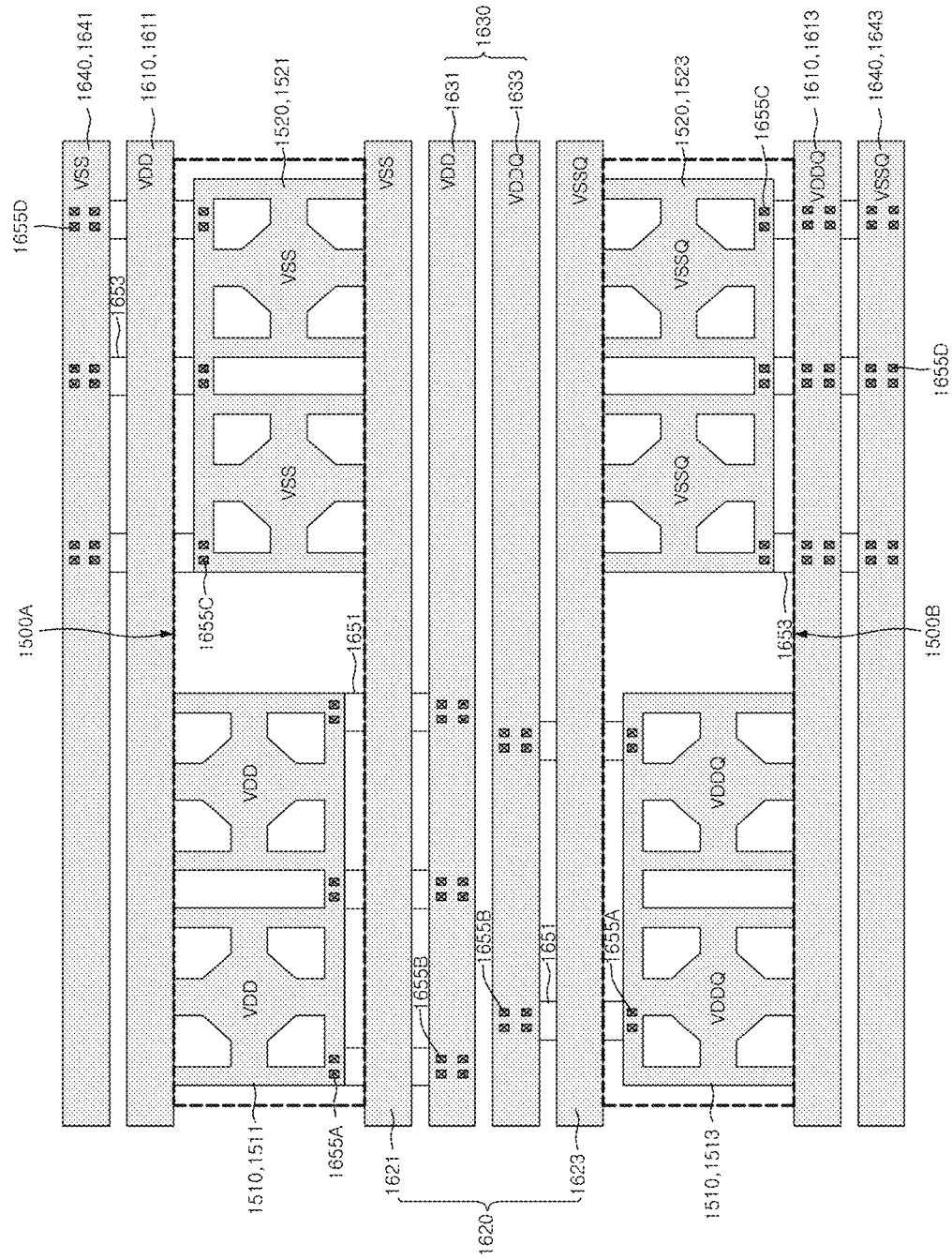
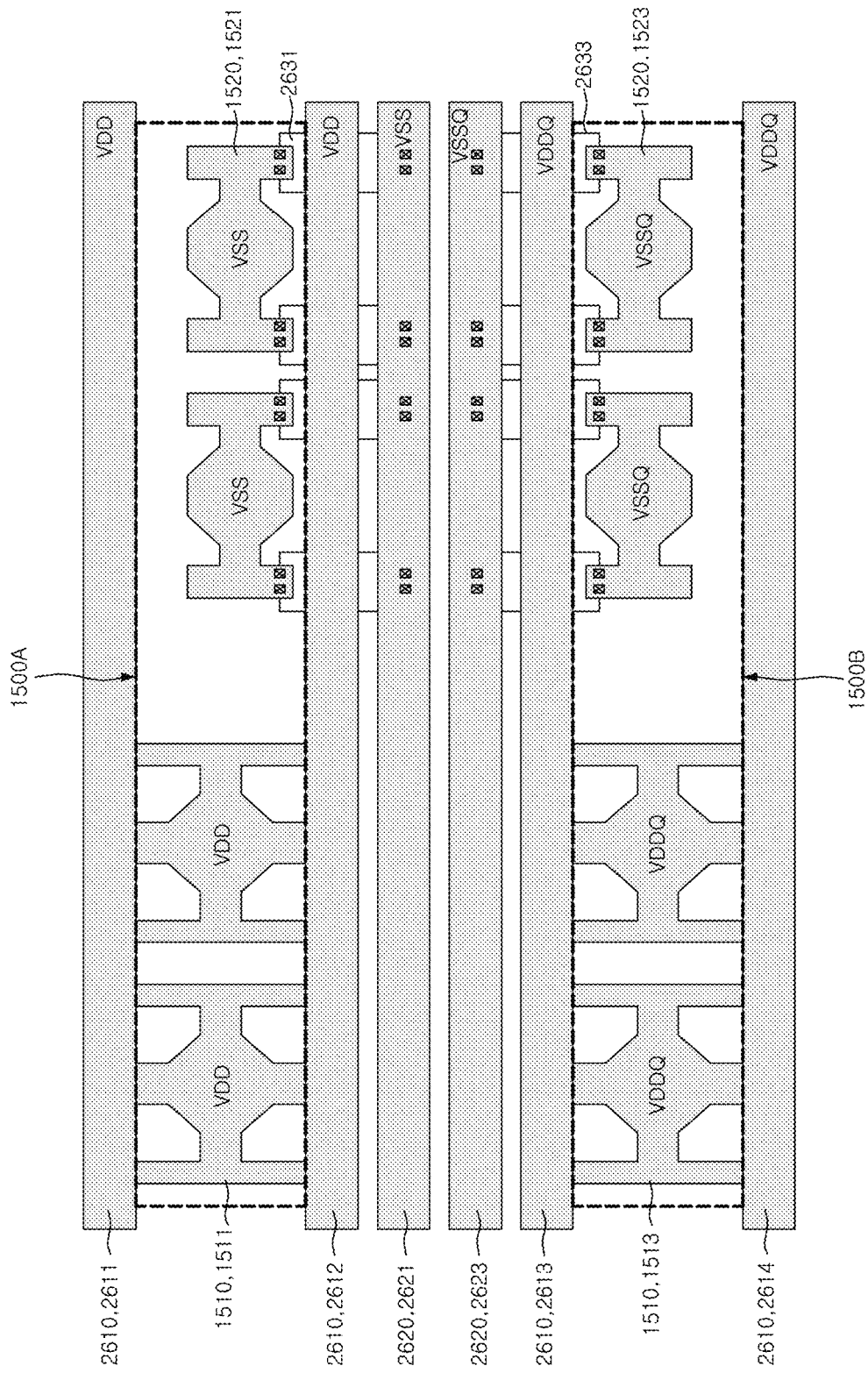


FIG. 5



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## SEMICONDUCTOR APPARATUS AND AN IMPROVED STRUCTURE FOR POWER LINES

### CROSS-REFERENCES TO RELATED APPLICATION

The present application claims priority under 35 U.S.C. §119(a) to Korean application number 10-2013-0167003, filed on Dec. 30, 2013, in the Korean Intellectual Property Office, which is incorporated herein by reference in its entirety.

### TECHNICAL FIELD

Various embodiments relate to a semiconductor apparatus, and more particularly, to a semiconductor apparatus which can efficiently lay out power lines electrically coupled to power supply pads.

### BACKGROUND

A semiconductor apparatus continuously trends toward high degree of integration, high capacity and high speed operation. In particular, various efforts have been made to realize a semiconductor apparatus of high performance within a limited area.

For example, as a semiconductor apparatus trends toward high performance, an increasing number of power lines are needed. As the number of power lines increases in this way, a structure for efficiently laying out the power lines is demanded.

### SUMMARY

In an embodiment, a semiconductor apparatus may include: a first power supply pad configured to supply a first power; a second power supply pad configured to supply a second power; a first power line configured to be directly electrically coupled to the first power supply pad; and a second power line configured to be directly electrically coupled to the second power supply pad.

In an embodiment, a semiconductor apparatus may include: one or more pad rows including one or more first power supply pads and one or more second power supply pads; a first power line laid out on one side of the pad rows in a direction perpendicular to the extending direction of the pad rows, and directly electrically coupled to the first power supply pads; and a second power line laid out on an other side of the pad rows in the direction perpendicular to the extending direction of the pad rows, and directly electrically coupled to the second power supply pads.

### BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a configuration diagram of a semiconductor apparatus in accordance with an embodiment;

FIG. 2 is a configuration diagram of bonding pads in the semiconductor apparatus shown in FIG. 1;

FIG. 3 is a diagram explaining the layout structure of power supply pads and power lines in a semiconductor apparatus in accordance with an embodiment;

FIG. 4 is a diagram explaining the layout structure of power supply pads and power lines in a semiconductor apparatus in accordance with an embodiment;

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FIG. 5 is a diagram explaining the layout structure of power supply pads and power lines in a semiconductor apparatus in accordance with an embodiment.

### DETAILED DESCRIPTION

Hereinafter, a semiconductor apparatus will be described below with reference to the accompanying drawings through various to embodiments.

Referring to FIG. 1, a semiconductor apparatus 10 in accordance with an embodiment includes a plurality of memory banks 110, 120, 130 and 140. The respective memory banks 110, 120, 130 and 140 are constituted by a plurality of cell mats which are arranged in a matrix type. Each cell mat includes a cell array region 1110, and driving circuit regions 1120, 1130 and 1140 which surround the cell array region 1110.

A plurality of signal lines (not shown) and a plurality of power lines (not shown) may be laid out over the respective memory banks 110, 120, 130 and 140. A plurality of signal lines may be laid out over the cell array region 1110, and a plurality of power lines may be laid out over the driving circuit regions 1120, 1130 and 1140.

The driving circuit regions 1120, 1130 and 1140 may include sense amplifier blocks 1120 which are laid out adjacent to a pair of facing edges of the cell array region 1110; and sub word line driving blocks 1130 which are laid out adjacent to a pair of facing edges of the cell array region 1110 in a direction perpendicular to a direction in which the sense amplifier blocks 1120 are laid out.

The semiconductor apparatus 10 in accordance with an embodiment further includes a peripheral circuit region 150 which is laid out between the plurality of memory banks 110, 120, 130 and 140. An address/command processing unit (not shown), a data input/output processing unit (not shown), a voltage supply unit (not shown), and so forth are laid out in the peripheral circuit region 150. Further, bonding pads (not shown), probing pads (not shown), and so forth may be laid out in the peripheral circuit region 150.

As shown in FIG. 2, the bonding pads include clock input pads CLK, command input pads CMD, address input pads Address, data strobe pads DQS, data input/output pads DQ, reference voltage pads VREF for input buffers, and a power supply pad array 1500.

The power supply pad array 1500 may be laid out in the peripheral circuit region 150 in such a way as to include one or more row of pads.

The power supply pad array 1500 plays the role of supplying power to the circuits of the semiconductor apparatus, and may include a first power supply pad POWER 1510 for supplying a first power and a second power supply pad GND 1520 for supplying a second power.

Referring to FIG. 3, the first power supply pad POWER 1510 may include power supply voltage pads 1511 (hereinafter, referred to as VDD pads 1511) which may be laid out in a first pad row 1500A and power supply voltage pads 1513 dedicated for output drivers (hereinafter, referred to as VDDQ pads 1513) which may be laid out in a second pad row 1500B.

The second power supply pad GND 1520 may include ground voltage pads 1521 (hereinafter, referred to as VSS pads 1521) which may be laid out in the first pad row 1500A and ground voltage pads 1523 dedicated for output drivers (hereinafter, referred to as VSSQ pads 1523) which may be laid out in the second pad row 1500B.

The power supply pad array 1500 may include a first pad row 1500A, and a second pad row 1500B which is separated from the first pad row 1500A in a first direction. The first

direction refers to a direction that is perpendicular to the extending direction of the first pad row **1500A**.

The first pad row **1500A** may include a plurality of VDD pads **1511** and a plurality of VSS pads **1521**. The plurality of VDD pads **1511** and the plurality of VSS pads **1521** may be laid out in a second direction. The second direction refers to the extending direction of the first pad row **1500A**.

The second pad row **1500B** may include a plurality of VDDQ pads **1513** and a plurality of VSSQ pads **1523**. The plurality of VDDQ pads **1513** and the plurality of VSSQ pads **1523** may be laid out in the second direction.

That is to say, each pad row may include both the first power supply pad **1510** and the second power supply pad **1520**.

Power lines for supplying power to various kinds of circuits (not shown) of the semiconductor apparatus may be electrically coupled to the power supply pad array **1500**. The power lines may include first power lines **1610** which are directly electrically coupled to the first power supply pad **1510**, and second power lines **1620** which are directly electrically coupled to the second power supply pad **1520**. The first power lines **1610** may be laid out on one side of the pad row **1500A** in a direction perpendicular to an extending direction of the pad row **1500A**. The second power lines **1620** may be laid out on the other side of the pad row **1500B** in the direction perpendicular to the extending direction of the pad row **1500B**.

The first power lines **1610** may include a power supply voltage power line **1611** (hereinafter, referred to as a VDD power line **1611**) which is directly electrically coupled to the VDD pads **1511**; and a power supply voltage power line **1613** dedicated for output drivers (hereinafter, referred to as a VDDQ power line **1613**) which is directly electrically coupled to the VDDQ pads **1513** that may be dedicated for an output driver. The VDD power line **1611** and the VDDQ power line **1613** may extend in the second direction.

The second power lines **1620** may include a ground voltage power line **1621** (hereinafter, referred to as a VSS power line **1621**) which is directly electrically coupled to the VSS pads **1521**; and a ground voltage power line **1623** dedicated for output drivers (hereinafter, referred to as a VSSQ power line **1623**) which is directly electrically coupled to the VSSQ pads **1523** that may be dedicated for an output driver. The VSS power line **1621** and the VSSQ power line **1623** may extend in the second direction. The VSS power line **1621** may be laid out on the other side or the one side of the first pad row **1500A** in the direction perpendicular to the extending direction of the first pad row **1500A**. The VSSQ power line **1623** may be laid out on the other side or the one side of the second pad row in the direction perpendicular to the extending direction of the second pad row **1500B**.

For example, the VDD power line **1611**, which is directly electrically coupled to the VDD pads **1511**, may be laid out on one side or an other side of the first pad row **1500A** in the first direction; and the VSS power line **1621**, which is directly electrically coupled to the VSS pads **1521**, may be laid out on the other side of the first pad row **1500A** in the first direction.

The VSSQ power line **1623**, which is directly electrically coupled to the VSSQ pads **1523**, may be laid out on one side of the second pad row **1500B** in the first direction; and the VDDQ power line **1613**, which is directly electrically coupled to the VDDQ pads **1513**, may be laid out on one side or the other side of the second pad row **1500B** in the first direction.

In other words, in the semiconductor apparatus, the first power lines **1610**, which are directly electrically coupled to the first power supply pad **1510**, may be laid out on the outer

sides of the pad rows **1500A** and **1500B** which include the first power supply pad **1510** and the second power supply pad **1520**; and the second power lines **1620**, which are directly electrically coupled to the second power supply pad **1520**, may be laid out on the inner sides of the pad rows **1500A** and **1500B**.

According to this fact, since the first power lines **1610** and the second power lines **1620** are directly electrically coupled to the pad rows **1500A** and **1500B**, it is possible to stably supply the first power and the second power to the various kinds of circuits of the semiconductor apparatus.

A semiconductor apparatus in accordance with an embodiment will be described below with reference to FIGS. **2** and **4**.

A power supply pad array **1500** of the semiconductor apparatus may include a first power supply pad **1510** and a second power supply pad **1520**. Since the power supply pad array **1500** is configured in the same manner as the power supply pad array **1500** of the aforementioned embodiment above, detailed descriptions thereof will be omitted herein.

Power lines for supplying power to various kinds of circuits (not shown) of the semiconductor apparatus may be electrically coupled to the power supply pad array **1500**. The power lines may include first power lines **1610** directly electrically coupled to the first power supply pad **1510**; second power lines **1620** directly electrically coupled to the second power supply pad **1520**; first auxiliary power lines **1630** indirectly electrically coupled to the first power supply pad **1510**; and second auxiliary power lines **1640** indirectly electrically coupled to the second power supply pad **1520**. The first power lines **1610** may be laid out above the first and second pad rows **1500A** and **1500B** and the first auxiliary power lines **1630**. The second power lines **1620** may be laid out between the pad row **1500A** and the second power auxiliary power lines **1640**. The first auxiliary power lines **1630** may be laid out on one side or the other side of the pad row **1500A** in the direction perpendicular to the extending direction of the pad row **1500A**. The second auxiliary power lines **1640** may be laid out on the other side or the one side of the pad row **1500B** in the direction perpendicular to the extending direction of the pad row **1500B**.

The first power lines **1610** may include a VDD power line **1611** directly electrically coupled to VDD pads **1511**, and a VDDQ power line **1613** directly electrically coupled to VDDQ pads **1513**.

The second power lines **1620** may include a VSS power line **1621** directly electrically coupled to VSS pads **1521**, and a VSSQ power line **1623** directly electrically coupled to VSSQ pads **1523**.

The first auxiliary power lines **1630** may include a power supply voltage auxiliary power line **1631** that may be dedicated for an output driver (hereinafter, referred to as a VDD auxiliary power line **1631**) indirectly electrically coupled to the VDD pads **1511**; and a power supply voltage auxiliary power line **1633** dedicated for output drivers (hereinafter, referred to as a VDDQ auxiliary power line **1633**) indirectly electrically coupled to the VDDQ pads **1513**.

The first auxiliary power lines **1630** and pad row are laid out on the same layer as the first power lines **1610** and at positions separated from the first power lines **1610** in the first direction. The first auxiliary power lines **1630** may be electrically coupled to the first power supply pad **1510** through first coupling lines **1651** which extend in the first direction.

The first coupling lines **1651** are laid out on a layer different from the first power supply pad **1510** and the first auxiliary power lines **1630** (for example, on an underlying layer) and the first power lines **1610**. The first power supply pad **1510** and the first coupling lines **1651** may be electrically coupled



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to each other through contacts **1655A**. Each pad of the pad row **1500B** and the first auxiliary power line **1630** may be electrically coupled to the first coupling lines **1651** through contacts **1655A**. The first auxiliary power lines **1630** and the first coupling lines **1651** may be electrically coupled to each other through contacts **1655B**.

The second auxiliary power lines **1640** may include a ground voltage auxiliary power line **1641** (hereinafter, referred to as a VSS auxiliary power line **1641**) indirectly electrically coupled to the VSS pads **1521**; and a ground voltage auxiliary power line **1643** dedicated for output drivers (hereinafter, referred to as a VSSQ auxiliary power line **1643**) indirectly electrically coupled to the VSSQ pads **1523**. The VSS auxiliary power line **1641** may be laid out on the other side or the one side of the first pad row **1500A** in the direction perpendicular to the extending direction of the first pad row **1500A**. The VSSQ auxiliary power line **1643** may be laid out on the other side or the one side of the second pad row **1500B** in the direction perpendicular to the extending direction of the second pad row **1500B**.

The second auxiliary power lines **1640** are laid out on the same layer as the pad row **1500B** and the second power lines **1620** and at positions separated from the second power lines **1620** in the first direction. The second auxiliary power lines **1640** may be electrically coupled to the second power supply pad **1520** through second coupling lines **1653** which extend in the first direction.

The second coupling lines **1653** are laid out on a layer different from the second power supply pad **1520** of the pad row **1500A**, the second power lines **1620** and the second auxiliary power lines **1640** (for example, on an underlying layer). The second power supply pad **1520** and the second coupling lines **1653** may be electrically coupled to each other through contacts **1655C**. Each pad of the pad row **1500B**, the second auxiliary power lines **1640** and the second coupling lines **1653** may be electrically coupled to each other through contacts **1655D**.

For example, the VDD power line **1611** directly electrically coupled to the VDD pads **1511**; and the VSS auxiliary power line **1641** indirectly electrically coupled to the VSS pads **1521** through the second coupling lines **1653**, may be laid out on one side of a first pad row **1500A** in the first direction. The VDD power line **1611** may be laid out at a position closer to the first pad row **1500A** than the VSS auxiliary power line **1641**.

The VSS power line **1621**, directly electrically coupled to the VSS pads **1521**; and the VDD auxiliary power line **1631** indirectly electrically coupled to the VDD pads **1511** through the first coupling lines **1651**, may be laid out on one side or the other side of the first pad row **1500A** in the first direction. The VDD auxiliary power line **1631** may be indirectly electrically coupled to the VDDQ pads **1513**. The VSS power line **1621** may be laid out at a position closer to the first pad row **1500A** than the VDD auxiliary power line **1631**.

The VDD power line **1611** and the VSS power line **1621** may be laid out at substantially the same distance from the first pad row **1500A**; and the VDD auxiliary power line **1631** and the VSS auxiliary power line **1641** may be laid out at substantially the same distance from the first pad row **1500A**.

The VSSQ power line **1623** directly electrically coupled to the VSSQ pads **1523**; and the VDDQ auxiliary power line **1633** indirectly electrically coupled to the VDDQ pads **1513** through the first coupling lines **1651**, may be laid out on one side or the other side of a second pad row **1500B** in the first direction. The VSSQ power line **1623** may be laid out at a position closer to the second pad row **1500B** than the VDDQ auxiliary power line **1633**.

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The VDDQ power line **1613** directly electrically coupled to the VDDQ pads **1513**; and the VSSQ auxiliary power line **1643** indirectly electrically coupled to the VSSQ pads **1523** through the second coupling lines **1653**, may be laid out on the other side of the second pad row **1500B** in the first direction. The VDDQ power line **1613** may be laid out at a position closer to the second pad row **1500B** than the VSSQ auxiliary power line **1643**.

The VDDQ power line **1613** and the VSSQ power line **1623** may be laid out at substantially the same distance from the second pad row **1500B**; and the VDDQ auxiliary power line **1633** and the VSSQ auxiliary power line **1643** may be laid out at substantially the same distance from the second pad row **1500B**.

In other words, the first power lines **1610** directly electrically coupled to the first power supply pad **1510** and the second auxiliary power lines **1640** indirectly electrically coupled to the second power supply pad **1520**, may be laid out on the outer sides of the pad rows **1500A** and **1500B**. The pad rows **1500A** may include the first power supply pad **1510**; the second power supply pad **1520**; the second power lines **1620** which are directly electrically coupled to the second power supply pad **1520**; and the first auxiliary power lines **1630**, which are indirectly electrically coupled to the first power supply pad **1510** and may be laid out on the inner sides of the pad rows **1500A** and **1500B**.

In the above-described structure, the first and second power lines **1610** and **1620** may be laid out at substantially the same distance from the pad rows **1500A** and **1500B**; and the first and second auxiliary power lines **1630** and **1640** may be laid out at substantially the same distance from the pad rows **1500A** and **1500B**.

According to this fact, since the first power lines **1610** and the second power lines **1620** are directly electrically coupled to the pad rows **1500A** and **1500B** and laid out between the pad rows **1500A** and **1500B** and the first auxiliary power lines **1630** and the second auxiliary power lines **1640** are indirectly electrically coupled to the pad rows **1500A** and **1500B** as described above, it is possible to stably supply a first power and a second power to the various kinds of circuits of the semiconductor apparatus.

A semiconductor apparatus in accordance with an embodiment will be described below with reference to FIGS. 2 and 5.

A power supply pad array **1500** of the semiconductor apparatus may include a first power supply pad **1510** and a second power supply pad **1520**. Since the power supply pad array **1500** is configured in the same manner as the power supply pad array **1500** of the aforementioned embodiments, detailed descriptions thereof will be omitted herein.

Power lines for supplying power to various kinds of circuits (not shown) of the semiconductor apparatus may be electrically coupled to the power supply pad array **1500**.

The power lines may include first power lines **2610** directly electrically coupled to the first power supply pad **1510**, and second power lines **2620** indirectly electrically coupled to the second power supply pad **1520**.

The first power lines **2610** may include VDD power lines **2611** and **2612** which are directly electrically coupled to VDD pads **1511**, and VDDQ power lines **2613** and **2614** which are directly electrically coupled to VDDQ pads **1513**.

The VDD power lines **2611** and **2612** may include a first VDD power line **2611** which is laid out on one side of a first pad row **1500A** in the first direction, and a second VDD power line **2612** which is laid out on the other side of the first pad row **1500A** in the first direction.

The VDDQ power lines **2613** and **2614** may include a first VDDQ power line **2613** laid out on one side of a second pad

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row **1500B** in the first direction; and a second VDDQ power line **2614** laid out on the other side of the second pad row **1500B** in the first direction.

The second power lines **2620** may include a VSS power line **2621** indirectly electrically coupled to VSS pads **1521** through first coupling lines **2631** extending in the first direction; and a VSSQ power line **2623** indirectly electrically coupled to VSSQ pads **1523** through second coupling lines **2633** extending in the first direction.

While certain embodiments have been described above, it will be understood to those skilled in the art that the embodiments described are by way of example only. Accordingly, the semiconductor apparatus described herein should not be limited based on the described embodiments. Rather, the semiconductor apparatus described herein should only be limited in light of the claims that follow when taken in conjunction with the above description and accompanying drawings.

What is claimed is:

1. A semiconductor apparatus comprising:

a first power line arranged in a first direction;

a second power line arranged to be parallel to the first power line;

a first power supply pad arranged between the first power line and the second power line to be directly connected to the first power line,

wherein an entire portion of the first power supply pad is arranged between the first power line and the second power line; and

a second power supply pad arranged between the first power line and the second power line and directly connected to the second power line,

wherein an entire portion of the second power supply pad is arranged between the first power line and the second power line;

a first auxiliary power line arranged to be parallel to the first power line and electrically coupled with the first power supply pad; and

a second auxiliary power line arranged to be parallel to the second power line and electrically coupled with the second power supply pad,

wherein the first power supply pad and the second power supply pad are arranged in a line.

2. The semiconductor apparatus according to claim 1,

wherein the first power supply pad comprises:

a power supply voltage pad and a power supply voltage pad dedicated for an output driver, and

the first power line comprises:

a first power supply voltage power line which is electrically coupled to the power supply voltage pad, and a second power supply voltage power line dedicated for an output driver, which is electrically coupled to the power supply voltage pad dedicated for an output driver.

3. The semiconductor apparatus according to claim 1,

wherein the second power supply pad comprises:

a first ground voltage pad and a second ground voltage pad dedicated for an output driver, and

wherein the second power line comprises:

a first ground voltage power line which is electrically coupled to the first ground voltage pad, and a second ground voltage power line dedicated for an output driver, which is electrically coupled to the ground voltage pad dedicated for an output driver.

4. A semiconductor apparatus comprising:

one or more pad rows including one or more first power supply pads and one or more second power supply pads;

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a first power line configured on one side of the pad rows in a direction perpendicular to the extending direction of the pad rows, and electrically coupled to the first power supply pads,

wherein an entire portion of the first power supply pads is arranged between the first power line and a second power line;

the second power line configured on an other side of the pad rows in the direction perpendicular to the extending direction of the pad rows, and directly electrically coupled to the second power supply pads,

wherein an entire portion of the second power supply pads is arranged between the first power line and the second power line;

a first auxiliary power line arranged to be parallel to the first power line and adjacent to the first power line; and

a second auxiliary power line arranged to be parallel to the second power line and adjacent to the second power line.

5. The semiconductor apparatus according to claim 4,

wherein the pad rows comprise:

a first pad row and a second pad row separated from the first pad row in a direction perpendicular to an extending direction of the first pad row.

6. The semiconductor apparatus according to claim 5,

wherein the first power supply pads comprise:

a power supply voltage pad configured in the first pad row, and a power supply voltage pad dedicated for an output driver, and configured in the second pad row, and

wherein the first power line comprises:

a first power supply voltage power line configured on one side or the other side of the first pad row in the direction perpendicular to the extending direction of the first pad row, and electrically coupled to the power supply voltage pad; and

a second power supply voltage power line dedicated for the output driver, configured on one side or the other side of the second pad row in the direction perpendicular to the extending direction of the second pad row, and electrically coupled to the power supply voltage pad dedicated for an output driver.

7. The semiconductor apparatus according to claim 6,

wherein the first auxiliary power line comprises:

a first power supply voltage auxiliary power line laid out on the one side or the other side of the first pad row in the direction perpendicular to the extending direction of the first pad row, and indirectly electrically coupled to the power supply voltage pad; and

a second power supply voltage auxiliary power line dedicated for an output driver, configured on the one side or the other side of the second pad row in the direction perpendicular to the extending direction of the second pad row, and indirectly electrically coupled to the power supply voltage pad dedicated for the output driver.

8. The semiconductor apparatus according to claim 7, wherein the first power line is configured above the pad row and the first auxiliary power line.

9. The semiconductor apparatus according to claim 8, wherein each pad of the pad row and the first auxiliary power line are electrically coupled to a first coupling line.

10. The semiconductor apparatus according to claim 9, wherein the pad row, the first power line and the first auxiliary power line are configured on substantially the same layer, and

wherein the first coupling line is configured on a layer different from the pad row, the first power line and the first auxiliary power line.

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11. The semiconductor apparatus according to claim 5,  
 wherein the second power supply pad comprises:  
 a first ground voltage pad which is configured in the first  
 pad row, and a second ground voltage pad dedicated for  
 an output driver, which is configured in the second pad  
 row, and

wherein the second power line comprises:

a first ground voltage power line configured on the other  
 side or the one side of the first pad row in the direction  
 perpendicular to the extending direction of the first pad  
 row, and electrically coupled to the ground voltage pad;  
 and

a second ground voltage power line dedicated for the out-  
 put driver, configured on the other side or the one side of  
 the second pad row in the direction perpendicular to the  
 extending direction of the second pad row, and electri-  
 cally coupled to the ground voltage pad dedicated for an  
 output driver.

12. The semiconductor apparatus according to claim 11,  
 wherein the second auxiliary power line comprises:

a ground voltage auxiliary power line configured on the  
 other side or the one side of the first pad row in the  
 direction perpendicular to the extending direction of the  
 first pad row, and indirectly electrically coupled to the  
 ground voltage pad; and

a ground voltage auxiliary power line dedicated for the  
 output driver, configured on the other side or the one side  
 of the second pad row in the direction perpendicular to  
 the extending direction of the second pad row, and indi-  
 rectly electrically coupled to the ground voltage pad  
 dedicated for an output driver.

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13. The semiconductor apparatus according to claim 12,  
 wherein the second power line is configured between the pad  
 row and the second auxiliary power line.

14. The semiconductor apparatus according to claim 13,  
 wherein each pad of the pad row and the second auxiliary  
 power line are electrically coupled to a second coupling line.

15. The semiconductor apparatus according to claim 14,  
 wherein the pad row, the second power line and the second  
 auxiliary power line are configured on substantially the  
 same layer, and

wherein the second coupling line is configured on a layer  
 different from the pad row, the second power line or the  
 second auxiliary power line.

16. The semiconductor apparatus according to claim 4,  
 wherein the first power line and the second power line are  
 configured at substantially the same distance from the pad  
 row.

17. The semiconductor apparatus according to claim 5,  
 wherein the first auxiliary power line is indirectly electri-  
 cally coupled to the first power supply pad of the pad row  
 and the second auxiliary power line is indirectly electri-  
 cally coupled to the second power supply pad of the pad  
 row, and

wherein the first auxiliary power line and the second aux-  
 iliary power line are configured at substantially the same  
 distance from the pad row.

18. The semiconductor apparatus according to claim 17,  
 wherein the first power lines are configured on an outer side of  
 the first pad row and the second pad row.

19. The semiconductor apparatus according to claim 18,  
 wherein the second power lines are configured on an inner  
 side of the first pad row and the second pad row.

\* \* \* \* \*